

Docket No.: M4065.0453/P453-B
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Eugene P. Marsh, et al.

Application No.: TBD

Group Art Unit: 2822

Filed: September 8, 2003

Examiner: M. Trinh

For: PROCESS FOR LOW TEMPERATURE
ATOMIC LAYER DEPOSITION OF RH

FIRST PRELIMINARY AMENDMENT

Box Patent Application
Commissioner for Patents
Washington, DC 20231

Dear Sir:

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

In the Specification

On page 2, before "Field of the Invention," please insert -- This application is a divisional of application Serial No. 10/283,316, filed October 30, 2002, which is turn is a divisional of Serial No. 09/884,997, filed on June 21, 2001, the disclosures of both of which are incorporated by reference herein.--

In the Claims

Please cancel claims 1-54.